



Image

AF/2814

Docket No.: 8733.132.20-US
(PATENT)

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:
Joon-Young Yang

Confirmation No.: 8761

Application No.: 09/875,197

Art Unit: 2814

Filed: June 7, 2001

Examiner: S. H. Rao

For: METHOD OF FABRICATING A THIN FILM
TRANSISTOR

Customer No.: 30827

REQUEST FOR RECONSIDERATION

MS AF
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

INTRODUCTORY COMMENTS

In response to the Office Action dated December 31, 2003 (Paper No. 12), Applicant respectfully requests that the above-identified Patent application be reconsidered in view of the remarks.

List of the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks begin on page 5 of this paper.